

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Confirmation No. 5086

Katsuhiko Miya

Date: December 22, 2006

Serial No.: 10/648,918

Group Art Unit: 1763

Filed: August 27, 2003

Examiner: Sylvia MACARTHUR

For: SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING  
METHOD DRYING SUBSTRATE

VIA EFS-WEB

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Entered with RCE 2/13/17  
mw 2/15/17AMENDMENT/SUBMISSION

Sir:

This is a response to the Office Action mailed September 22, 2006 in the above-identified application. Reconsideration of the application is respectfully requested.

FEE CALCULATION

Any additional fee required has been calculated as follows:

\_\_\_\_\_ If checked, "Small Entity" status is claimed.

	NO. CLAIMS AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR		EXTRA PRESENT		RATE	ADDIT. FEE
TOTAL	33	MINUS	33	* =	0	X	(\$25 SE or \$50)	\$0
INDEP.	3	MINUS	3	** =	0	X	(\$100 SE or \$200)	\$0
FIRST PRESENTATION OF MULTIPLE DEPENDENT CLAIM						X	(\$180 SE or \$360)	\$0

\* not less than 20 \*\* not less than 3

TOTAL \$0

If any additional payment is required, a check which includes the calculated fee of \$ \_\_\_\_\_  
(OFGS Check No. \_\_\_\_\_) is attached.